

<b>Notice of References Cited</b>	Application/Control No. 10/510,328	Applicant(s)/Patent Under Reexamination CICHUTEK ET AL.	
	Examiner Maria B. Marvich, PhD	Art Unit 1633	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,013,516	01-2000	Verma et al.	435/325
*	B	US-5,212,084	05-1993	McClure et al.	435/235.1
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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**NON-PATENT DOCUMENTS**

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